

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re	Application of:	)
HIDEYUKI ANDOH		)
		) Art Unit: 2813
Serial No. 10/013,087		)
		) Examiner: SCHILLINGER, LAURA M.
Filed:	<b>DECEMBER 7, 2001</b>	)
	,	)
For:	SEMICONDUCTOR DEVICES AND THE	)
	MANUFACTURING METHOD OF	)
	THE SAME	)

I hereby certify that this correspondence is being deposited with the United States Postal Service as certified first class mail in an envelope addressed to: Mail Stop Issue Fee, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on

6/22/2004

Janie Wilkins

## AMENDMENT AFTER ALLOWANCE UNDER 37 CFR 1.312

Mail Stop Issue Fee Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Subject to the approval of the Examiner, please enter the following amendments.

Amendments to the Specification begin on page 2 of this paper.

Remarks begin on page 3 of this paper.